

**UNIVERSITY OF WARWICK**  
**Arts Faculty Research and Impact Committee**  
**14:00 – 16:00, Thursday 13<sup>th</sup> November 2025, FAB 2.32**

**AGENDA**

Ref	Item	Purpose	Lead	Report Type	Report Classification
001	<b>Welcome and Apologies for absence</b>				
002	<b>Declarations of interest</b>				
003	<b>Minutes of meeting held on 18<sup>th</sup> June 2025</b>	Approval	Alison Riberio de Menezes	003-AFRIC131125	Confidential
<b>Governance</b>					
004	<b>Membership and Terms of Reference 2025-26</b>	Approval	Alison Riberio de Menezes	Verbal	n/a
<b>Chair's Update</b>					
005	<b>Chair's Business and Actions</b>	Information	Alison Riberio de Menezes	Verbal	n/a
<b>PGR</b>					
006	<b>Postgraduate Research and CADRE update - New faculty scholarship management group</b>	Information	David Lambert	006-AFRIC131125	Confidential
<b>Strategic Development and Review</b>					
007	<b>Research Centre Review - Process, Recommendation, and Implementation</b>	Discussion/ Approval	Carole Harris	007-AFRIC131125	Confidential
008	<b>CreaTech at Warwick</b>	Information	Rachel Moseley	Verbal	n/a
009	<b>European Partnerships - Update</b>	Information	George Christou	009-AFRIC131125 Presentation	Confidential
<b>Research &amp; Impact</b>					
010	<b>Warwick Institute of Engagement Update</b>	Information	James Hodkinson	Verbal	n/a
011	<b>Updates on Impact Support</b>	Information	Lesley Chikoore	011-AFRIC131125	General
012	<b>Faculty of Arts research funding applications and awards</b>	Information	Alan Ashton-Smith	012-AFRIC131125	Confidential
013	<b>Humanities Research Centre Update</b>	Information	William Rupp	Verbal	n/a
<i>Items below this line are for receipt and/or approval, without discussion</i>					
<b>Subsidiary and Sub-Committee Reports</b>					
<b>Other</b>					
	<b>Matters arising from meeting held on 18<sup>th</sup> June 2025</b> MT to disseminate Research Culture Survey to Faculty				
<b>CLOSE BY 16:00</b>					
<b>Next meeting: 14.00 – 16.00, Tuesday 10<sup>th</sup> February 2026, C0.02, Zeeman Building</b>					